

# CMOS-MEMS (2)

### Dong-II "Dan" Cho

School of Electrical Engineering and Computer Science, Seoul National University Nano/Micro Systems & Controls Laboratory

> Email: dicho@snu.ac.kr URL: http://nml.snu.ac.kr

# Contents

- Case study: ADXL05/50
- Case study: ADXRS150/300
- Case study: 3-axis accelerometer

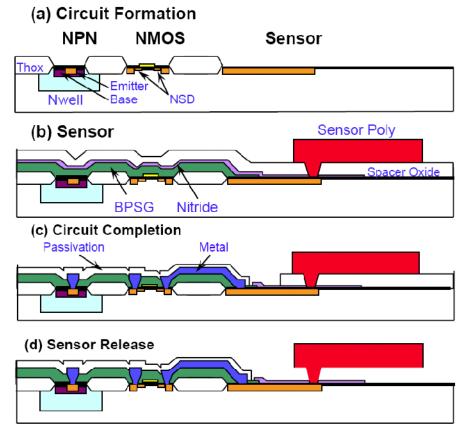


# Case study: ADXL05/50



# Intermediate-CMOS accelerometer

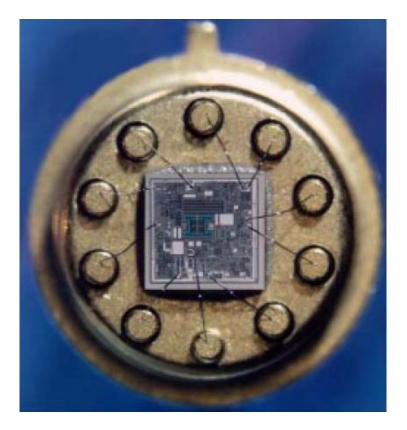
- iMEMS process by Analog Devices, Inc.
  - Intermediate-CMOS process





# Intermediate-CMOS accelerometer (Cont'd)

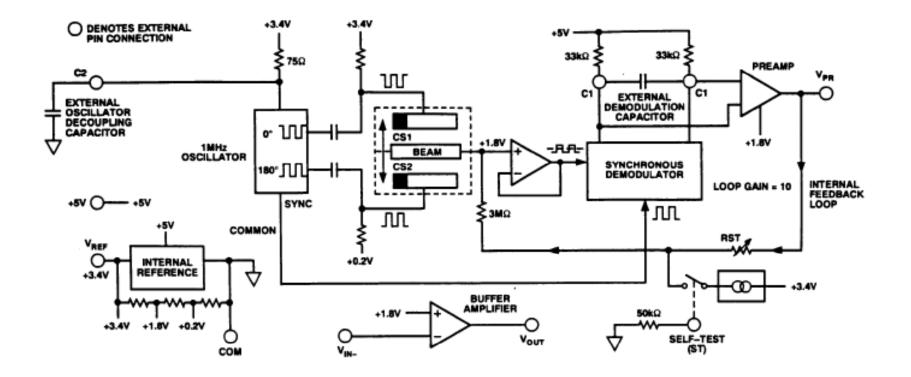
- ADXL05/50
  - First commercialized microaccelerometer





# Intermediate-CMOS accelerometer (Cont'd)

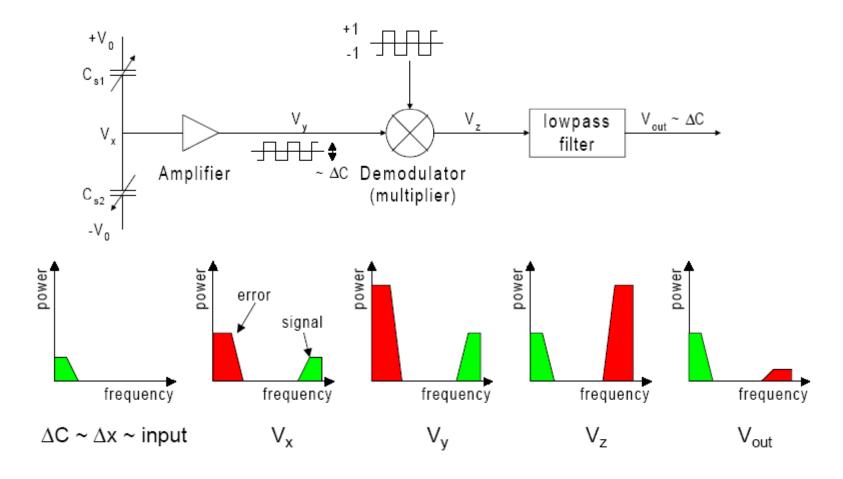
• Functional block diagram





# Intermediate-CMOS accelerometer (Cont'd)

• Noise & drift reduction



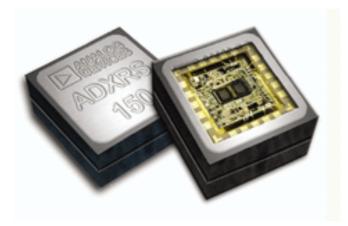


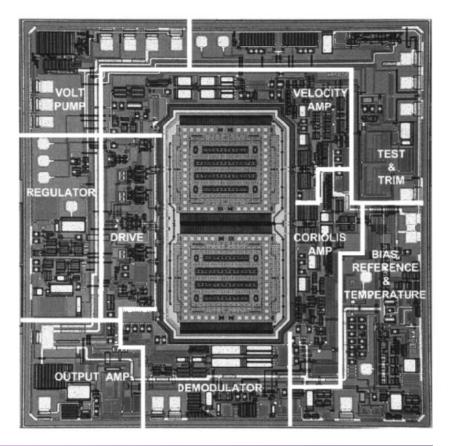
# Case study: ADXRS150/300



# Intermediate-CMOS gyroscope

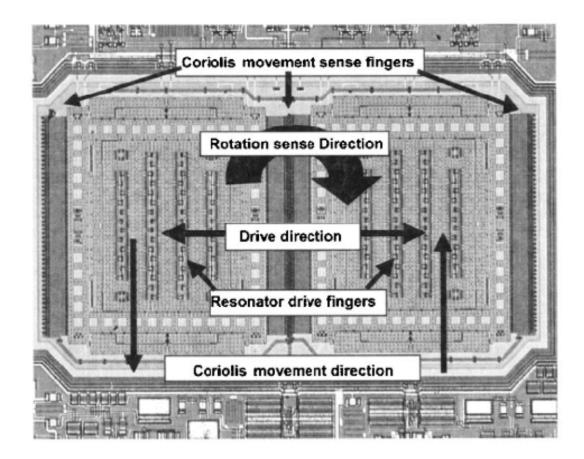
- ADXRS150/300
  - First monolithic-integrated microgyroscope by ADI





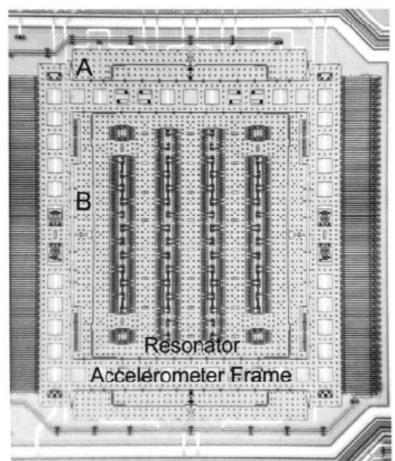


• Mechanical structure overview



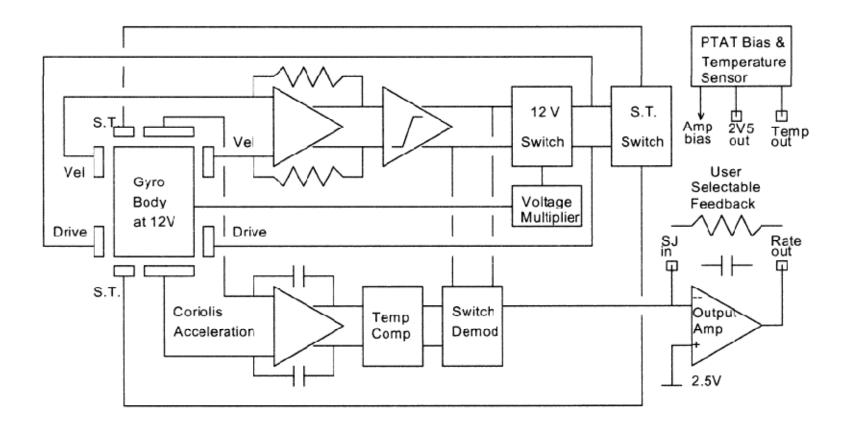


- Mechanical structure (Half of tuning folk)
  - Quadrature control levers





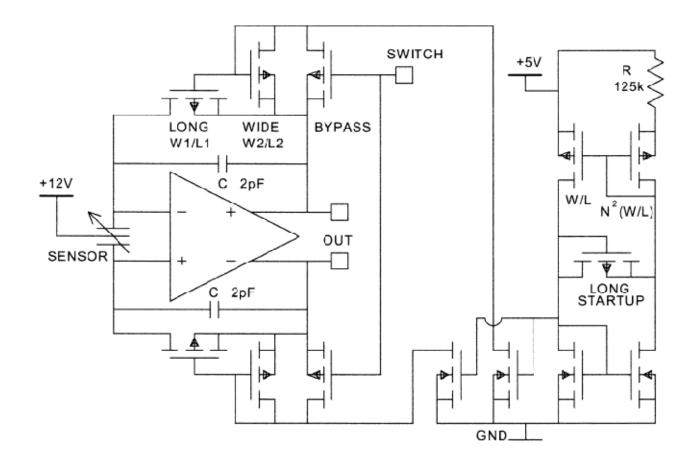
Block diagram





**Dong-II "Dan" Cho** This material is intended for students in 4541.844 class in the Spring of 2008. Any other usage and possession is in violation of copyright laws

• Analog front-end design



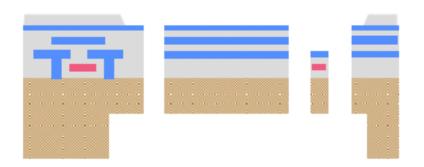


# Case study: 3-axis Accelerometer

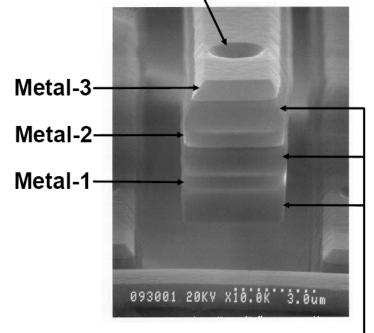


# **Post-CMOS 3-axis Accelerometer**

• Fabrication process



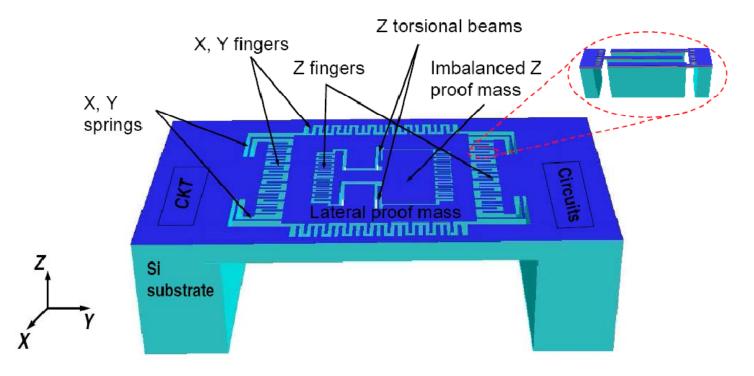
#### Via from Metal-3 to Metal-2



#### Oxide layers



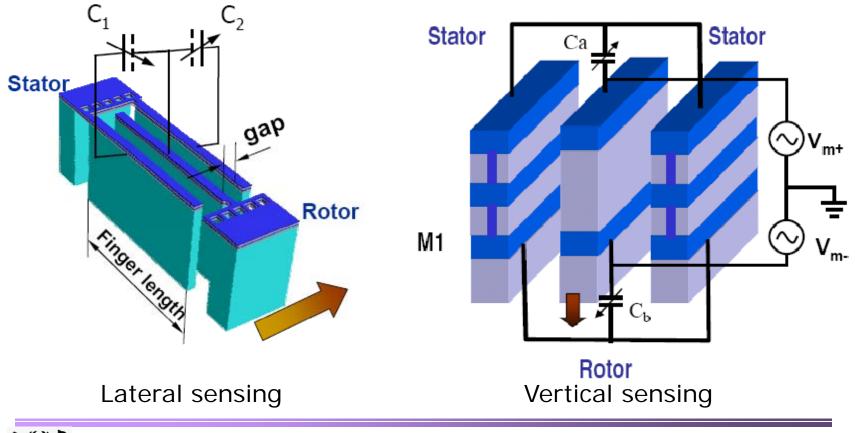
- 3-axis accelerometer
  - H. Qu, et al, Solid State Sensors Workshop, Hilton Head Island, 2006





**Dong-II "Dan" Cho** This material is intended for students in 4541.844 class in the Spring of 2008. Any other usage and possession is in violation of copyright laws

Sensing mechanism



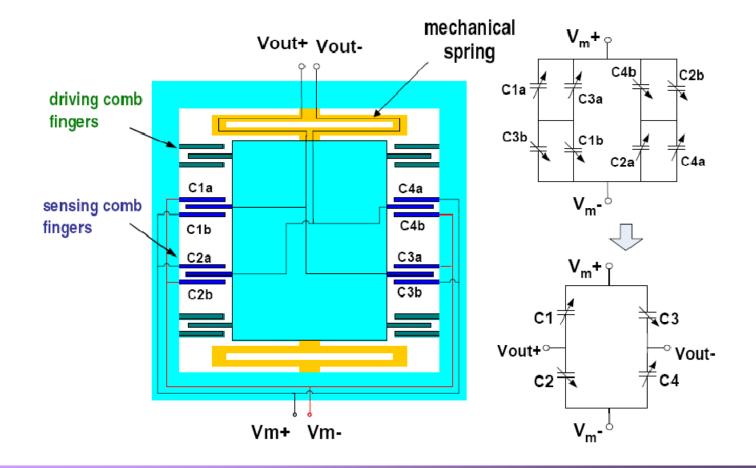


Dong-II "Dan" Cho

Nano/Micro Systems & Controls Lab.

This material is intended for students in 4541.844 class in the Spring of 2008. Any other usage and possession is in violation of copyright laws

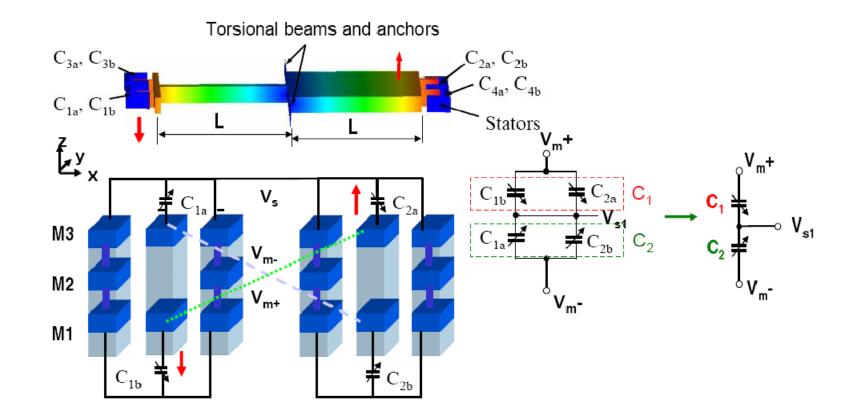
• Lateral accelerometer





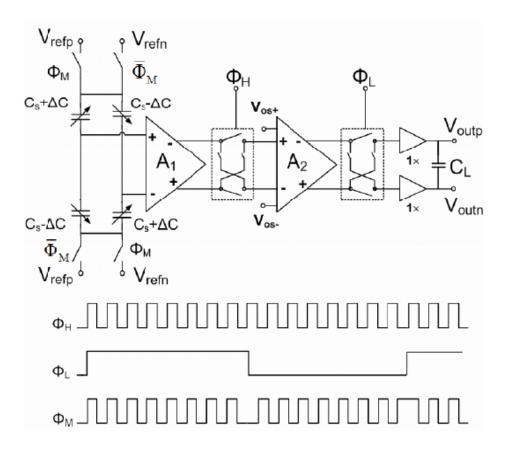
**Dong-II "Dan" Cho** This material is intended for students in 4541.844 class in the Spring of 2008. Any other usage and possession is in violation of copyright laws

• Vertical accelerometer



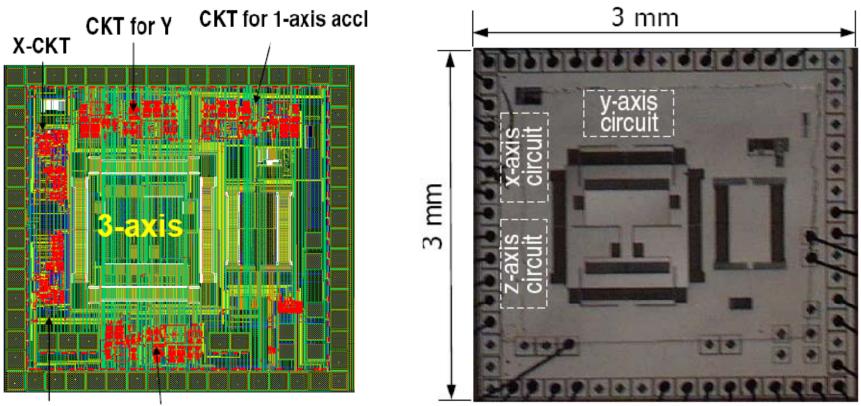


• Readout electronics





• Final layout and fabrication results



#### Z-CKT Test CKT



## Reference

- [1] Marc J. Madou, "Fundamentals of MICROFABICATION," 2nd edition
- [2] Analog Devices, ADXL50
- [3] R. C. Jaeger, "Introduction to Microelectronic Fabrication," 2nd edition
- [4] H. Qu, et al, Solid State Sensors Workshop, Hilton Head Island, 2006
- [5] Geen. J, et al, Journal of Solid-state Circuits, 2007



**Dong-II "Dan" Cho** This material is intended for students in 4541.844 class in the Spring of 2008. Any other<sup>22</sup> usage and possession is in violation of copyright laws